



## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service, postage prepaid, in an envelope, addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 11-14-05, PATENT

Dated: November 14, 2005 By: Dolores L. Keag.

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Abdalla Aly Naem, et al.

Appln. No.: 10/772,863

Filed: February 4, 2004

For: METHOD OF FORMING A MOS  
TRANSISTOR WITH A LAYER OF  
SILICON GERMANIUM CARBON (as  
amended)

Group Art Unit: 2823

Examiner: William M. Brewster

AMENDMENT IN RESPONSE TO OFFICE  
ACTION MAILED AUGUST 23, 2005

### INTRODUCTORY COMMENTS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action mailed August 23, 2005, please amend the above-identified application as indicated in the following:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper;

**Remarks** which begin on page 4 of this paper; and

**Appendix A** which begins on page 8 of this paper.

AMENDMENT IN RESPONSE TO OFFICE  
ACTION MAILED AUGUST 23, 2005

Atty. Docket No. 100-19810  
(P05402-D01)